

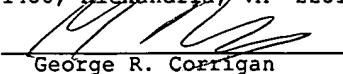


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SUPPLEMENTAL INFORMATION DISCLOSURE CITATION					APPLICANT Huismann et al.			
					FILING DATE December 5, 2003	GROUP 3742		
U.S. PATENT DOCUMENTS								
EXAM. INIT.	REF	PATENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE	
		4,441,012	4/3/84	Risbeck et al.				
		4,780,594	10/25/88	Rothermel				
		6,008,470	12/28/99	Zhang et al.				
		6,201,216	3/13/01	Mumaw				
FOREIGN PATENT DOCUMENTS								
EXAM INIT	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
		SU 1,743,752A1	6/30/92	Union of Soviet Union				
		DE4204661C1		Germany				
		DE4118208A1		Germany				
OTHER DOCUMENTS (Including Author, Title, Date, Pages, Etc.)								
		Direct Control Of The Material Transfr: The Controlled Shrt Circuiting (CSC) - Mig Process, G. Huismann						
EXAMINER				DATE CONSIDERED				
EXAMINER: Initial if citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

CERTIFICATE OF MAILING/TRANSMISSION (37 CFR 1.84)
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